

DECLARATION FOR PATENT APPLICATION

99S0875-1

As a below named inventor, I declare:

that I verily believe myself to be the original, first and sole (if only one individual inventor is listed below) or an original, first and joint inventor (if more than one individual inventor is listed below) of the invention in

METHOD AND APPARATUS FOR MANUFACTURING A SEMICONDUCTOR DEVICE

the specification of which is attached hereto unless the following box is checked.

☐ was filed on _____ as United States Application
or PCT International Application No. _____ and
was amended on _____ (if applicable).

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information of which is material to patentability as defined in 37 CFR 1.56.

I hereby claim foreign priority benefits under 35 U.S.C. 119(a)-(d) or 365 (b) of any foreign application(s) for patent or inventor's certificate, or 35 U.S.C. 365(a) of any PCT International application which designated at least one country other than the United States, listed below and have also identified below any foreign application for patent or inventor's certificate, or PCT International application having a filing date before that of the application on which priority is claimed:

Country	Category	Application No.	Filing Date	Priority Claim
Japan	Patent	11-139820	May 20, 1999	Yes
Japan	Patent	11-228521	August 12, 1999	Yes
Japan	Patent	11-280266	September 30, 1999	Yes

And I hereby appoint Stuart Lubitz (Reg.No. 20,680), Richard H. Zaitlen (Reg.No. 27,248), Alex Chartove (Reg.No. 31,942), David M. Simon (Reg.No. 32,756), Jay M. Finkelstein (Reg.No. 21,082), Roger R. Wise (Reg.No. 31,204), William K. Konrad (Reg.No. 28,868), Louis A. Mok (Reg.No. 22,585), John P. Scherlacher (Reg.No. 23,009), Gary D. Mann (Reg.No. 34,867), Don F. Livornese (Reg.No. 32,040), Ted Rittmaster (Reg.No. 32,933), Paul H. Kovelman (Reg.No. 35,228), David L. Lubitz (Reg.No. 38,229), Paul G. Nagy (Reg.No. 37,896), Weining Yang (Reg.No. 38,690), Chris P. Perque (Reg.No. 37,696), Joseph F. Vonsauers (Reg.No. 27,253), Philippe O. Erwin (Reg.No. 38,132), David W. Victor (Reg.No. 39,867), Jonathan Y. Kang (Reg.No. 38,199) and Randall C. Furlong (Reg.No. 35,144), each of whose address is 10100 Santa Monica Boulevard, Suite 2200, Los Angeles, California 90067-4164, or anyone of them my attorneys with full power of substitution and revocation to prosecute this application and to transact all business in the Patent & Trademark Office connected therewith, and request that correspondence be directed to Loeb & Loeb LLP, 10100 Santa Monica Boulevard, Suite 2200, Los Angeles, California 90067-4164.

I declare further that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

DECLARATION FOR PATENT APPLICATION

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I declare further that my citizenship, residence and post office address are as stated below next to my name:

Inventor: (Signature)DateResidence and post office addressMasataka Kondo

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Masataka KONDO, et al.

Serial No: 09/531,549

Filed: March 20, 2000

For: A METHOD OF FORMING A THIN FILM
ON A SUBSTRATE OF A
SEMICONDUCTOR DEVICE (As
Amended)

Art Unit: 2818

Examiner: D. Le

I hereby certify that this correspondence
is being deposited with the United States
Postal Service with sufficient postage as
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to:

Commissioner for Patents
Washington D.C. 20231, on

December 11, 2000

Date of Deposit

Kathleen J. Dunn

Name

December 11, 2000

Signature

Date

(1) NOTICE OF CHANGE OF ATTORNEY'S ADDRESS

and

(2) ASSOCIATE POWER OF ATTORNEY

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

(1) Notice of Change of Attorney's Address

Please direct all future communications in connection with the above-entitled
application to the attorney of record at the following new address:

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(2) Associate Power of Attorney

Please recognize the following as my associate attorneys in the above-entitled
application:

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Respectfully submitted,

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